Application/Control No. Applicant(s)/Patent Under Reexamination 09/856,779 LIANG ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Brian R. Peugh 2187 **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY US-Α US-В US-С US-D US-Ε US-F US-G US-Н US-US-J US-Κ US-L US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Ρ Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) Java Virtual Machine Profiler Interface (JVMPI). Last modified Nov. 11, 1998, pages 18-50. W

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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